Docket No.

198322US-2 CCN

IN RE APPLICATION OF: Taka

SERIAL NO: 09/680,513

FILED:

October 6, 2000

FOR:

EXPOSURE METHOD, EXPOSURE APPARATUS AND MAKING METHOD...

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- Additional documents filed herewith: Marked-Up Copy, Request for Extension of Time (1 month)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	49	MINUS	58	0	× \$18 =	\$0.00
INDEPENDENT	12	MINUS	12	0	× \$84 =	\$0.00
□ MULTIPLE DEPENDENT CLAIMS + \$280 =				\$0.00		
			TOTAL OF A	BOVE CALCU	JLATIONS	\$0.00
□ Reduction by 50% for filing by Small Entity				\$0.00		
		□ Recor	dation of Assignment		+ \$40 =	\$0.00
L					TOTAL	\$0.00

- A check in the amount of **\$110.00** is attached.
- Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Tel. (703) 413-3000 Fax. (703) 413-2220

(OSMMN 10/00)

GJM/CES/maj I:\atty\CES\198322US.pto.wpd

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Gregory J. Maier

Registration No. 25,599

Carl E. Schlier

Registration No. 34,426

> James D. Hamilton Registration No. 28,421

198322US-2 CONT APR 0 4 2002 &

IN THE COUTED SPATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

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TAKAHIRO HORIKOSHI ET AL.

: GROUP ART UNIT: 2851

SERIAL NO: 09/680,513

:

FILED: OCTOBER 6, 2000

: EXAMINER: BROWN, K.

FOR: EXPOSURE METHOD, EXPOSURE

APPARATUS AND MAKING METHOD OF THE APPARATUS, AND DEVICE AND

MANUFACTURING METHOD OF

THE DEVICE

AMENDMENT UNDER 37 C.F.R. §1.116

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Responsive to the Office Action dated December 4, 2001, please amend the aboveidentified application as follows:

IN THE CLAIMS

Please amend the claims as shown in the marked-up copy attached. A clean copy of the claims is shown below.

1. (Twice Amended) An exposure method performed by an exposure apparatus to transfer a pattern illuminated with exposure light from a light source onto a substrate, said method comprising:

photodetecting a part of said exposure light in an optical path of said exposure light; setting a time interval for measurement of a transmittance of said optical system which is arranged between a position of photodetecting a part of said exposure light and said substrate in accordance with changes in exposure conditions;

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